



PATENT  
Attorney Docket No. 0553-0147.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hisashi Ohtani

Serial No.: 09/916,913

Filed: July 27, 2001

Examiner: L. Malsawma

Art Unit: 2825

For: METHOD OF MANUFACTURING  
THIN FILM TRANSISTOR

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NAME: Kristine Callahan

SIGNATURE: *Kristine Callahan*

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT G

Dear Sirs:

In response to the Office Action dated January 30, 2004, please amend the above-identified application as follows: